

AMENDMENT / RESPONSE TRANSMITTAL

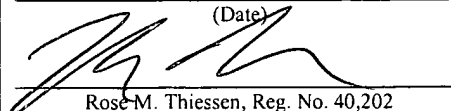
Applicant : Vanhaelemeersch, et al.
App. No. : 10/078,284
Filed : 15-Feb-2002
For : METHOD OF FABRICATING
A SEMICONDUCTOR
DEVICE
Examiner : Estrada, M.
Art Unit : 2823

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

November 13, 2003

(Date)

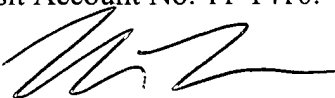

Rose M. Thiessen, Reg. No. 40,202

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

- (X) Response to Restriction Requirement in 1 page.
- (X) Return prepaid postcard.
- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.



Rose M. Thiessen
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Vanhaelemeersch, et al.
Appl. No. : 10/078,284
Filed : February 15, 2002
For : METHOD FOR FABRICATING
A SEMICONDUCTOR DEVICE
Examiner : Estrada, M.
Group Art Unit : 2823

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Rose M. Thiessen, Reg. No. 40,202

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In an Office Action mailed November 5, 2003, the Examiner imposed a Restriction Requirement. In connection therewith, the Examiner asserted that the application claimed the following inventions: Claims 1-15, drawn to a method of making a semiconductor device (Group I); and Claims 16-30, drawn to a semiconductor device (Group II).

Applicants hereby elect the invention of Group I, including Claims 1-15, drawn to a method of making a semiconductor device, without traverse and without prejudice. The Examiner is invited to call the undersigned attorney if it is desirable to discuss any issues raised in this Response.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: Nov. 13, 2003

By:

Rose M. Thiessen
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